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2700 PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Naomasa SHIRAISHI

Application No.: 09/869,121

Docket No.: 109919

Filed: October 15, 2001

For: METHOD AND APPARATUS FOR PRODUCING MASK

REQUEST FOR CORRECTION OF PALM RECORDS

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. Also attached is a corrected application data sheet. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

Joel S. Armstrong
Registration No. 36,430

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Date: December 17, 2001

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

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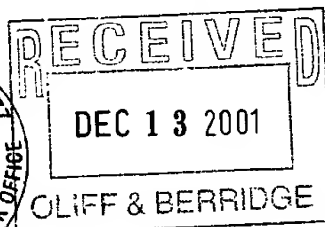
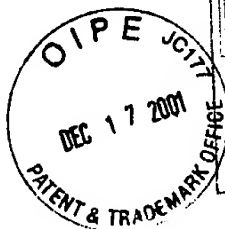
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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO.	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/869,121	10/15/2001	1756	1230	109919	5	18	6

Oliff & Berridge
PO Box 19928
Alexandria, VA 22320



CONFIRMATION NO. 1222

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Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Naomasa Shiraishi,  SAITAMA-SHI, Tokyo, JAPAN;

Domestic Priority data as claimed by applicant

THIS APPLICATION IS A 371 OF PCT/JP99/07093 12/17/1999

Foreign Applications

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Projected Publication Date: Not Applicable, filed prior to November 29, 2000

Non-Publication Request: No

Early Publication Request: No

Title

Method and apparatus for producing mask

Preliminary Class

430

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Inventor Information

Inventor One Given Name:: Naomasa
Family Name:: SHIRAISHI
City of Residence:: Saitama-shi
Country of Residence:: JAPAN
Citizenship Country:: JAPAN

Correspondence Information

Correspondence Customer Number:: 25944

Application Information

Title Line One:: METHOD AND APPARATUS FOR PRODUCING
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Continuity Information

>This application is a:: 371 of
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Prior Foreign Applications

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Priority Claimed:: YES

Assignee Information

Name of assignee:: NIKON CORPORATION
Assignee Address Line One:: Fuji Bldg., 2-3, Marunouchi 3-chome,
City:: Chiyoda-ku
State or Province:: Tokyo
Country:: JAPAN
Postal or Zip Code:: 100-8331